

Notice of References Cited

Application/Control No.

10/597,939

Applicant(s)/Patent Under
Reexamination
ZHENG ET AL.

Examiner

JUN LI

Art Unit

1793

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Abstract of Shen et al (CN85100996)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.